

INFORMATION DISCLOSURE STATEMENT

Applicant : Satoh *et al.*
App. No : 10/759,953
Filed : January 16, 2004
For : SEMICONDUCTOR-PROCESSING
DEVICE PROVIDED WITH A
REMOTE PLASMA SOURCE FOR
SELF-CLEANING
Examiner : Jeffrie Robert Lund
Art Unit : 1792
Conf. No. : 8185

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 4 references to be considered by the Examiner. Also enclosed are 3 non-patent literature references as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed after the mailing date of a final action or after the mailing date of a Notice of Allowance. This Statement is accompanied by the fee set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(2)


I hereby certify that no item of information contained in this Statement was cited in a communication from a foreign Patent Office in a counterpart foreign application, and, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than 3 months prior to the filing of this Information Disclosure Statement.

Appl. No. : 10/759,953
Filed : January 16, 2004

Docket No. ASMJP.055DV1
Customer No. 20,995

Respectfully submitted,
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 2/20/09

By: 

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